

15915 U.S. PTO
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23911
PATENT TRADEMARK OFFICE
21906 U.S. PTO
10/615926

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July 10, 2003

Mail Stop PATENT APPLICATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Re: New U.S. Patent Appln.
Our Ref: 010986.52578US

Sir:

Transmitted herewith for filing is the patent application of:

Hideaki YAMASAKI and Yumiko KAWANO

entitled: **Film-Formation Apparatus and Source Supplying Apparatus
Therefor, Gas Concentration Measuring Method**

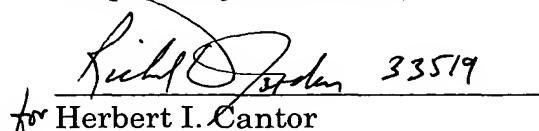
Enclosed are:

1. Specification, including 29 claims (pages 55).
2. 16 Sheets of Formal drawings showing Figs. 1-16.
3. Declaration and Power of Attorney.
4. Application Data Sheet
5. Assignment of the invention to Tokyo Electron Limited
6. Priority is being claimed under 35 U.S.C. §119 and 37 C.F.R. §1.55 based on Priority Document 2002-201532, filed in Japan on July 10, 2002 and. Priority Document 2003-191044, filed in Japan on July 3, 2003
7. The filing fee has been calculated as shown below:

Basic Fee				\$375/750	= \$750.00
Total Claims	<u>29</u>	-	<u>20</u>	= <u>9</u>	x \$9/18 = \$162.00
Independent Claims	<u>4</u>	-	<u>3</u>	= <u>1</u>	x \$42/84 = \$ 84.00
Multiple Dependent Claim Presented				\$140/280	= \$
Total Filing Fee					<u>\$996.00</u>

Two checks, one in the amount of \$996.00 for the filing fee and \$40.00 for the Assignment recording fee are enclosed. The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Deposit Account No. 05-1323 (Docket #010986.52578US). A duplicate copy of this sheet is enclosed.

Respectfully submitted,


for Herbert I. Cantor
Reg. No. 24,392

HIC:tcv